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DEC 29 2005

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application

Inventor(s): Tue Nguyen, Tai Dung Nguyen
Appl. No.: 09/898,439
Confirm. No.: 1885
Filed: July 5, 2001
Title: PLASMA SEMICONDUCTOR PROCESSING
SYSTEM AND METHOD

PATENT APPLICATION

Art Unit: 2818
Examiner: Quoc Dinh Hoang
Customer No. 23910

CERTIFICATE OF TRANSMISSION/MAILING

I hereby certify that this correspondence is being facsimile transmitted to the USPTO or deposited with the U.S. Postal Service with sufficient postage as first class mail in an envelope addressed to: Mail Stop AF, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on December 29, 2005.

Sheldon R. Meyer
Signature Date: December 29, 2005

(Signature)

REPLY TO FINAL OFFICE ACTION

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This is a response to the Office Action mailed July 29, 2005, setting a period for response expiring on October 29, 2005. A Petition for Extension of Time is being submitted herewith to extend the response period to December 29, 2005.

Amendments to the Claims are reflected in the listing of claims which begins on page 5 of this paper.

Remarks/Arguments begin on page 5 of this paper.

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